

Methodology of Additive production in the Nanostructures NbXFe₂-XO₄ Ferrite by Laser Ablation CuHBr

(1)C.A. Reis de Freitas, (1) G. Vasconcelos (2)M.R.F.Gontijo (2) M.R.da Silva, (3)F.C.L. Melo.

(1) IEAv – Instituto de Estudos Avançados, Rodovia dos Tamoios km 5,5, São José dos Campos – SP, CEP 12228-840, E-mail: careis@ieav.cta.br, getulio@ieav.cta.br,

(2) UNIFEI - Universidade Federal de Itajubá, Departamento de Física e Química, Instituto de Ciências Exatas, Avenida BPS, 1303, Itajubá-MG, CEP 37.500-903,
E-mail: mrsilva@unifei.edu.br ,mrobert@ieav.cta.br

(3) IAE-Instituto de Aeronáutica e Espaço, Praça Marechal Eduardo Gomes, 50. Campus do CTA Vila das Acácias, São José dos Campos – SP, CEP 12228-904,
E-mail: frapi@iae.cta.br.

Abstract – The proposal of this work is to present the methodology of the additive production in the BaNb_xFe_{2-x}O₄ ferrite. Discuss a model to obtainment the nanostructured samples using laser ablation equipment, in substitution the traditional ceramic method to making additives of BaNb_xFe_{2-x}O₄.

With the development of the nanotechnology, become present in the technology of ferrite production, for several applications in the industrial sector such as telecommunications, aeronautics, medicinal, etc. and the properties of the materials of size of grains dependence's [1, 2, 3, 4, and 5]. Therefore, the intention of this work is to demonstrate that the technology using laser ablation is capable to produce ferrites in the nanometers scale, by increasing the performance in its electric and magnetic characterization, being a different technique obtained size grains illustrated in Fig 3 in relation to the traditional ceramic

-MILLING PROCESS LASER METHOD

The milling process laser method is realized for one laser CuHBr, in function of the potency variation and the volume of the distilled water, illustrated in Figs 1 and 3

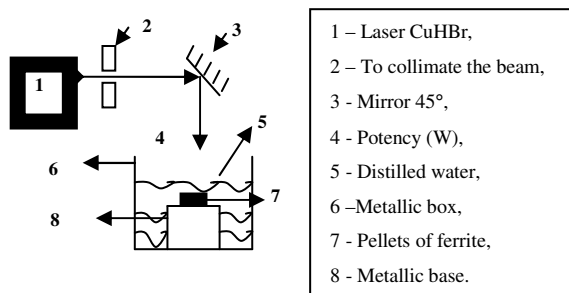


Figure 1: Equipment project for milling process laser, CuHBr



Figure 2: Laser, CuHBr

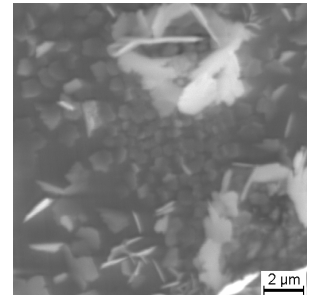


Figure 3: Size of grains of The additive nanostructured BaNb_xFe_{2-x}O₄

REFERENCES

- [1] Centro Técnico Aeroespacial, "Processo para Obtenção de Revestimentos Absorvedores de Microondas 2 -20 GHz à Base de Poliuretanos e Resinas Epóxi Aditados com Partículas de Carbono e Ferritas", Patente - Código de Registro: PI9805581, Dezembro 1998.
- [2] Centro Técnico Aeroespacial, - "Processo para Obtenção de Manta Flexível para Absorção de Radiação Eletromagnética na Faixa de 2 - 20 GHz à Base de Poliuretanos Aditados com Ferrita, Fibras e/ou Partículas de Carbono", Patente - deposito em Dezembro 1998 Código do Registro: PI9806680, Dezembro 1998.
- [3] Y. C. De Polli, A. C. C. Migliano, C. R. S. Stopa, S. I. Nabeta and J. R. Cardoso, "Finite Element Analysis of Impedance of an Electron Beam Current Monitor", *IEEE Transactions on Magnetics*, vol. 35. NO. 3, pp1833-1836, May 1999.
- [4] A. C. C. Migliano, Y. C. De Polli, C. R. Stopa and S. I. Nabeta, "Simulation of the Electron Beam Current Monitor Using a Finite Element Method Coupled with Circuit", *Anais The Brazilian Conference on Electromagnetics- CBMAG98*. São Paulo, Brasil, vol. 1, pp284-287, Ed. Sociedade Brasileira de Eletromagnetismo, October 1998.
- [5] Centro Técnico Aeroespacial, "Processo de Fabricação de Monitor de Corrente de Elétrons não Interceptante", Patente - Código do Registro: PI9902434, Junho 1999.nte", Patente - Código do Registro: PI9902434, Junho 1999.